ABSTRACT

"HOUSING FOR A LASER PROCESSING MACHINE AND LASER PROCESSING MACHINE HAVING A HOUSING"

A housing (4) for a laser processing machine (1) is described comprising a dividing wall (9), which separates a first work space (7) and a second work space (8), and a covering device (10), which is configured to selectively cover at least one between the first work space (7) and the second work space (8). The covering device (10) comprises at least a cover (32; 33), which is controllable in an active configuration, in which the cover (32; 33) is configured to cover one between the first work space (7) and the second work space (8) and a guide system (34), which is configured to guide the cover (32; 33) so that the cover (32; 33), when it is in the active configuration, comprises at least a main portion (35) and an auxiliary portion (36) extending from the main portion (35) and being inclined relative to the main portion (35).

FIG. 5